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**ABSTRACT**

**METHOD AND ARTICLE OF MANUFACTURE FOR  
MICRO-LENS RESULTING FROM  
MULTI-STAGE FABRICATION TECHNIQUE**

5 Micro-lenses are formed on the surface of a semiconductive circuit through a plurality of processing stages. In each stage, an alternate lens placement pattern is imparted  
10 onto micro-lens suitable material. Unwanted material is removed and micro-lenses are formed from the remaining material. Subsequent stages are applied until all desired micro-lenses in a structure are defined and formed from alternate placement patterns.

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